

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Keshner, M.

DOCKET NO: 200308866-1

SERIAL NO.: 10/618,478

EXAMINER: Bret P. Chen

FILED: July 11, 2003

ART UNIT: 1762

TITLE: ROLL-VORTEX PLASMA CHEMICAL VAPOR DEPOSITION SYSTEM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Weiss & Moy, P.C.
4204 N. Brown Avenue
Scottsdale, AZ 85251-3989

CORRECTED COMPLIANT AMENDMENT

Dear Sir:

In response to a September 27, 2006 Notice of Non-Compliant Amendment, Applicant hereby submits a corrected Amendment to the Specification, Abstract and Claims sections of the Non-Compliant Amendment previously submitted on September 5, 2006. Amendments to the Specification begin on page 2, amendments to the Abstract begin on page 3, amendments to the Claims begin on page 4, and the Remarks begin on page 10 of this Amendment.

Please amend the subject patent application as follows: